



MICRON.250C1

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Li, et al. )  
)  
App. No. : 10/602,483 )  
)  
Filed : June 24, 2003 )  
)  
For : ELIMINATION OF DENDRITE )  
FORMATION DURING )  
METAL/CHALCOGENIDE GLASS )  
DEPOSITION )  
)  
Examiner : Unknown )

REVOCATION OF POWER OF ATTORNEY

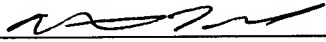
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The undersigned hereby revokes any previous powers of attorney in the subject application, namely that of Knobbe, Martens, Olson & Bear, LLP, including all of the individual members of the firm, 2040 Main Street, Fourteenth Floor, Irvine, California 92614, and requests that all future communications with respect thereto from the Patent and Trademark Office be forwarded to Tom D'amico of Dickstein, Shapiro, Morin, & Oshinsky, located at 2101 L Street NW, Washington, DC 20037-1526.

Micron Technology, Inc.

Dated: 9-11-2003

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